



Docket No. 82478-4700

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Shiro Iida et al.

Serial No.: 10/762,986

Filed: January 21, 2004

For: ARC TUBE MANUFACTURING METHOD  
THAT REDUCES UNEVENNESS IN  
THICKNESS OF A PHOSPHOR LAYER ON  
AN INNER SURFACE OF A BENT GLASS  
TUBE

Patent Examiner: Unknown

Group Art Unit:

April 7, 2004

Irvine, California 92614

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

In an attempt to fully comply with the duty of disclosure set forth in 37 C.F.R. § 1.56 and in conformance with 37 C.F.R. §§ 1.97 and 1.98, applicant wishes to bring to the attention of the U.S.

Patent Office the following references:

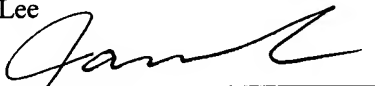
Japanese Laid-open Patent Application No. 10/50259 (which corresponds with U.S. Patent No. 5,731,659).

A copy of this reference and a form PTO-A820 are attached.

If the Examiner believes that a telephone conference would help further the prosecution of this case, he is respectfully requested to contact the undersigned attorney at the listed telephone number.

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Commissioner for Patent, PO Box 1450, Alexandria, VA 22313-1450 on April 7, 2004

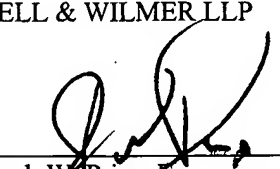
by: James Lee

  
Signature

Date of Signature: April 7, 2004

Very truly yours,

SNELL & WILMER LLP

  
Joseph W. Price, Esq.

Reg. No. 25,124

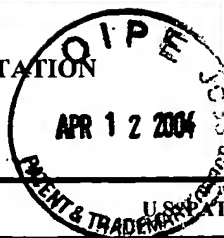
1920 Main Street, Suite 1200

Irvine, CA 92614

Phone 949/253-4920

# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



Docket Number (Optional)

82478-4700

Application Number

10/762,986

Applicant(s)

Shiro Iida et al.

Filing Date

January 21, 2004

Group Art Unit

Unknown

## PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		10/50259	02/20/1998	Japan				✓

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.